

Docket No.: 1999P2416

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : MANFRED FRANK ET AL.  
Filed : CONCURRENTLY HEREWITH  
Title : SCRATCH-RESISTANT COATING FOR SEMICONDUCTOR  
COMPONENT



INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

U.S. Patent 5,479,049 (Aoki et al.), dated December 26, 1995;

European Patent Application 0 152 744 A1 (Arndt et al.), dated August 28, 1985;

European Patent Application EP 0 791 899 A2 (Setlak), dated August 27, 1997;

European Patent Application EP 0 915 373 A1 (Yau et al.), dated May 12, 1999;

Patent Abstracts of Japan 11 135 691 A (Ryoji et al.), dated May 21, 1999;

International Search Report, dated August 2, 1999.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "W. Stemer".

For Applicants

WERNER H. STEMER  
REG. NO. 34,956

Date: February 4, 2002

Lerner and Greenberg, P.A.  
Post Office Box 2480  
Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
Fax: (954) 925-1101  
/kf

<b>FORM PTO-1449 (SUBSTITUTE)</b>  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>INFORMATION DISCLOSURE          STATEMENT BY APPLICANT</b> (37 CFR 1.98(b))				Attorney Docket No.: 1999P2416 Appl. No.  Applicant MANFRED FRANK ET AL.  Filing Date February 4, 2002 Group Art Unit			
EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,479,049	12/26/95	Aoki et al.			
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
<b>FOREIGN PATENT DOCUMENT</b>							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	0 152 744 A1	8/28/85	Europe			
	K	0 791 899 A2	8/27/97	Europe			
	L	0 915 373 A1	5/12/99	Europe			
	M	11 135 691 A	5/21/99	Japan			
	N						
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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 10/06/16
